

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Karl-Heinz SCHUSTER

Application No.: 10/700,315

Filed: October 31, 2003

For: Interferometer Apparatus and  
Method of Processing a Substrate Having  
an Optical Surface

Customer No.: 20350

Confirmation No. 5458

Examiner: Hwa S. Lee

Technology Center/Art Unit: 2877

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed October 13, 2006, on the above-referenced application, please enter the following amendments and remarks:

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 12 of this paper.